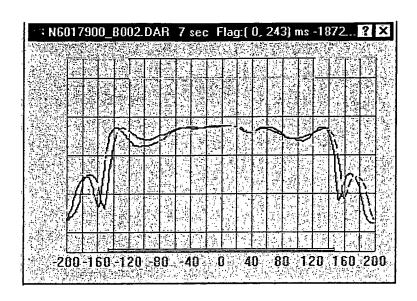
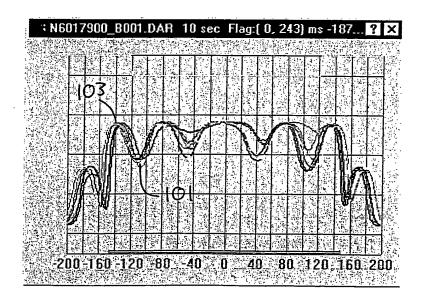


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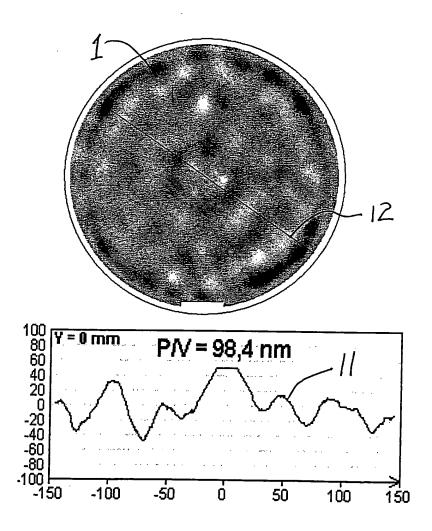
FIGURE 1 A





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FIGURE 2



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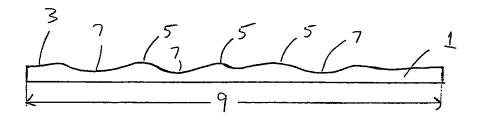


FIGURE 3.

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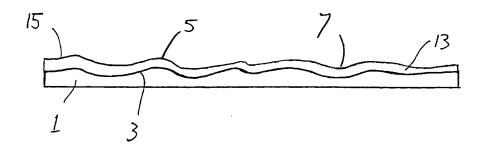


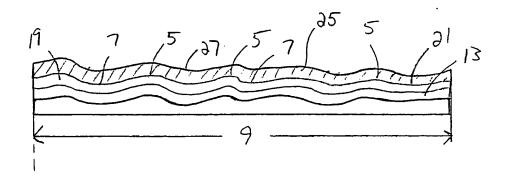
FIGURE 4

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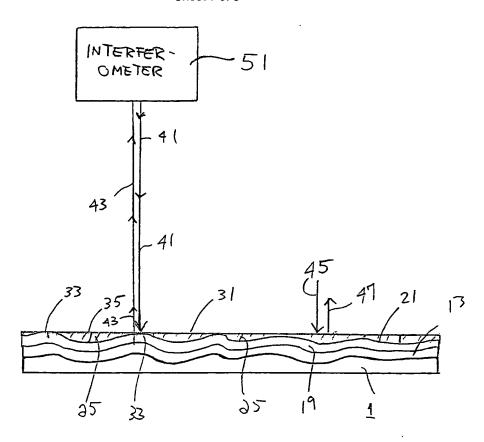


FIGURE 7

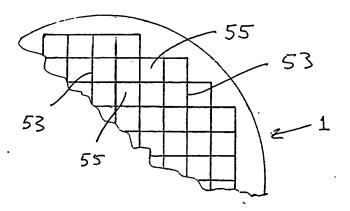


FIGURE 8

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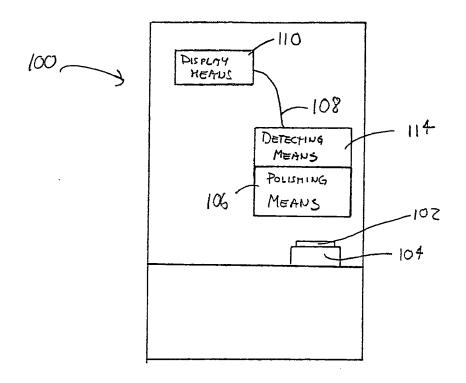


FIGURE 9